



TIN OXIDE AND TITANIUM DIOXIDE BASED CO₂ GAS SENSOR

Gajanan Trymbakappa Lamdhade

Department of Physics, Vidya Bharati Mahavidyalaya, CK Naidu Road, Camp, Amravati Maharashtra State 444 602, INDIA
gtlamdhade@rediffmail.com, oumgajanan@gmail.com

Received 19-02-2015, online 30-05-2015

ABSTRACT

The influence of CO₂ gas concentration on the transport properties of SnO₂-10Al₂O₃-10TiO₂ oxide thick films has been studied. From the X-RD spectra the average crystallite size of the samples is found to be of the order of 10.80 nm to 56.05 nm and shows polycrystalline and granular nature. For a fixed concentration of gas the sensitivity decreases with increase in temperature, but increases with increasing concentration of CO₂ gas. Transient response of the samples was studied. The resistance of all the samples increases by increasing the concentration of CO₂ gas, due to oxidization process on the surface of the material.

Keywords: Metal oxide thin films, electrical conductivity, transient response, CO₂ gas Sensor.

I. INTRODUCTION

The hetero-structure mechanism and the amorphous nature of the samples are important for the sensing devices. Ceramic and amorphous materials may be the best sensors for sensing the present gases. Most of the research workers have studied the electrical resistance of the material in presence of CO₂ gas environment. Today multi-functioning sensors are available in the market but now there is a need to develop the best sensor for sensing the single gas only. The semiconductor metal oxide materials are generally used in the form of wafer (thin pellet) or film (thin or thick) deposited on a substrate (glass, silica, silicon, alumina, steatite etc.). Gas sensors in the form of thin or thick films seems to be more promising detectors over the pellet form, because they are potentially of low cost, rugged and have low consumption of electric power and more active surface area.

A sensor array comprising of three chemical gas sensors was evaluated to predict the concentrations of O₂, CO and CO₂ in a gas stream at 600°C [1]. The sensors in the array included a resistance-based 2% CuO/10% La₂O₃/TiO₂ material and yttrium stabilized zirconium (YSZ) sensor with a metal/metal oxide internal reference electrode and a lithium phosphate-based sensor. Electrochemical impedance spectroscopy (EIS) was used to study the electrical properties of heat treated electrochemical gas sensors [2]. In the present paper solid solution of metal oxides SnO₂-10TiO₂-10Al₂O₃ in the form of thick films is selected. The pure TiO₂ and Al₂O₃ are mixed with SnO₂ for the improvement of temperature characteristic and stability respectively.

II. EXPERIMENTAL DETAILS

The thick films of tin oxide (SnO₂), titanium oxide (TiO₂) and alumina (Al₂O₃) were prepared by screen-printing technique on chemically clean optically plane glass substrate. The X-ray diffraction (XRD, Rigaku X-ray diffractometer, Japan) analyses of thick films was conducted using Cu K α radiation to determine the different phases and the grain size. The crystallite size was calculated from the full width at half maximum of the first peak using the Scherrer's formula [3].

The thickness of the sensor films was measured by Digimatic Outside Micrometer (Series-293, Japan) having a resolution of ± 0.001 mm and found to be 7.45, 40.09 and 73.34 μ m for (SnO₂-10TiO₂-10Al₂O₃) solid solution, pure SnO₂ and pure TiO₂ sensors respectively. The resistance of the sensor was measured by voltage drop method adopted by Yawale *et al* [4, 5]. By knowing sensor resistance the sensitivity was calculated.

III. RESULTS AND DISCUSSION:

Tin oxide (SnO₂) is a wide energy gap n-type semiconductor. It is used as sensor because of its chemical and mechanical stability. The fig.1 shows the XRD spectra of (SnO₂-10TiO₂-10Al₂O₃) solid solution and shows polycrystalline and granular nature of the selected oxides. From fig. 1 it is observed that XRD spectra contains 10–15 peaks which are due to SnO₂ and TiO₂. The (*h*, *k*, *l*) values are obtained by using 2θ and *d*-values. Tin dioxide has one stable state called as rutile. Anatase phase of TiO₂ changes to rutile when heated above temperature 500 °C along with SnO₂ and Al₂O₃ [6, 7]. So the structure of TiO₂ and SnO₂ is same. The lattice parameter values obtained for SnO₂ and TiO₂ are $a = b = 4.7382$ °Å and $c = 3.1871$ °Å with *c/a* ratio of 0.6726 and $a = 4.5933$ °Å and $c = 2.9595$ °Å with *c/a* ratio of 0.6442, respectively. These values are in agreement with the values reported in references [8, 9]. The rutile phase is stable and because of the same structure of SnO₂ and TiO₂, the space group and atom location sites changes the Ti⁴⁺ by Sn⁴⁺ metallic cation. Similarly the Al₂O₃ which is added as stabilizer to SnO₂-TiO₂ material, forms hexagonal phase with $a = 4.758$ °Å and $c = 12.925$ Å°. These phases are playing very important role for sensing the CO₂ gas [10, 11].

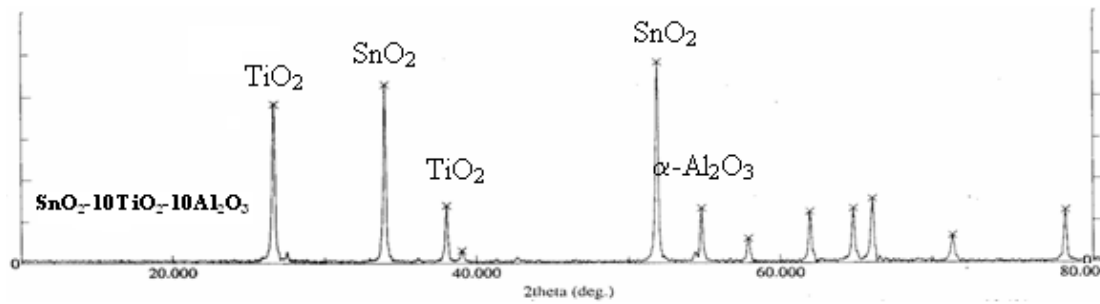


Figure 1: X-RD spectra of $(\text{SnO}_2-10\text{TiO}_2-10\text{Al}_2\text{O}_3)$ thick film

The average crystallite size calculated using FWHM and ON time and OFF time of various sensor parameters are reported in the table 1.

Table 1: Crystallite size and response time of sensors.

SN	Composition (mol %)	crystallite size (nm)	Sensitivity (s) at 500ppm at 313K	Response Time (sec)	
				ON time	OFF time
1	Pure SnO_2	56.05	10.19	90	105
2	Pure TiO_2	10.80	5.57	75	105
3	$\text{SnO}_2-10\text{TiO}_2-10\text{Al}_2\text{O}_3$	10.80	26.07	60	105

Fig. 2 shows the variation of sensitivity with change in concentration of CO_2 gas at different temperatures 313K, 323K, 333K and 343K for sensor $(\text{SnO}_2-10\text{TiO}_2-10\text{Al}_2\text{O}_3)$. From figure 2, it appears that the sensitivity decreases by increasing temperature of thick films. At lower concentration of gas a linear behavior is observed whereas at higher concentration, the plot deviates from linearity. At higher temperature range the change in the sensitivity with concentration is small. The sensor sensitivity (S) is proportional to the number of active centers on the surface of sensor. The number of active centers is the product of surface area and surface density of the active centers. The specific surface is a ratio of surface area to mass of the sensor therefore; the sensor sensitivity is proportional to the product of specific surface, density of active centers and the sensor mass. So if the specific surface is more, the number of active centers will be more and therefore the higher sensitivity of the material [12]. The TiO_2 doped polycrystalline SnO_2 sensor shows higher sensitivity just as in metal oxide $(\text{SnO}_2-10\text{TiO}_2-10\text{Al}_2\text{O}_3)$ thick film.

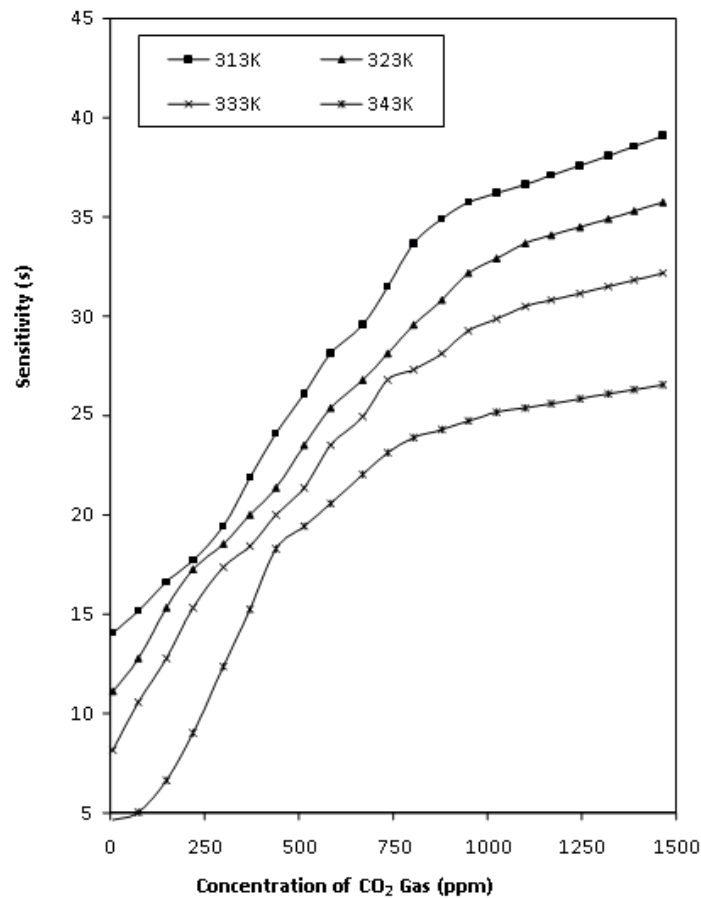


Figure 2: Variation of sensitivity with concentration of CO_2 gas at different temperatures for $\text{SnO}_2-10\text{TiO}_2-10\text{Al}_2\text{O}_3$ thick film.

Fig. 3 shows the variation of sensitivity with temperature at constant concentration of CO₂ gas (1465ppm) for the thick film (SnO₂-10TiO₂-10Al₂O₃), pure SnO₂ and pure TiO₂. These plots are found to be linear. It is seen that the sensitivity of solid solution is more than the pure SnO₂ and pure TiO₂ at higher and lower concentration of CO₂ gas.

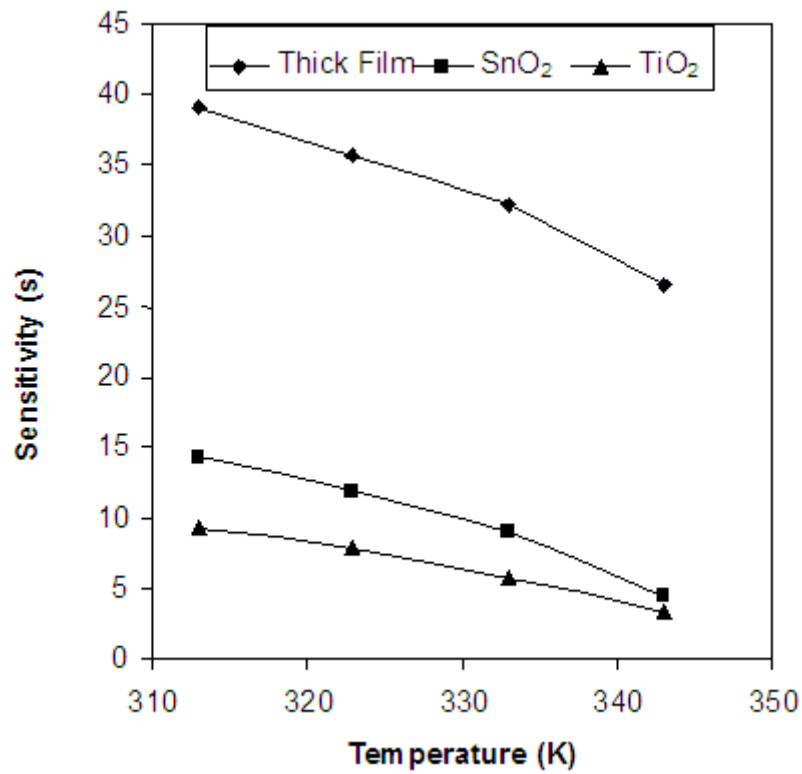


Figure 3: Variation of sensitivity with temperature at constant concentration of CO₂ gas (1465ppm)

Fig.4: shows the variation of sensitivity with change in concentration of CO₂ gas for the solid solution, SnO₂ and TiO₂ thick films at constant temperature (313K). In all the films the sensitivity increases linearly for the lower concentration range but for higher concentration range it deviates from linearity. It is also observed that the sensitivity change in solid solution thick film is more than SnO₂ and TiO₂ films.

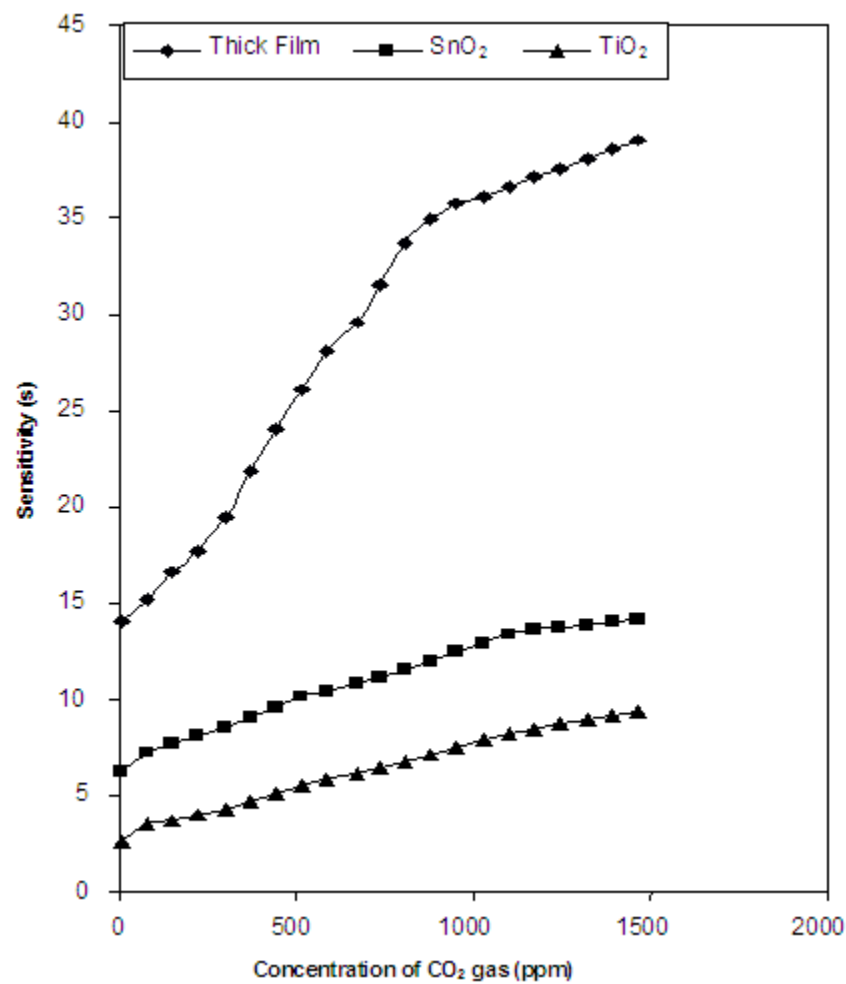


Figure 4: Variation of sensitivity with concentration of CO₂ gas at constant temperature (313K)

Fig. 5 shows the transient response of the solid solution thick film, SnO₂ and TiO₂ at 500-ppm concentration of CO₂ gas. It is observed that the solid solution has 75 s ON time and 105 s OFF time whereas for the pure SnO₂ film the ON time and OFF time is 90 and 105 s respectively. But it is also noted that, pure TiO₂ has minimum OFF time and higher ON time. This shows that the addition of TiO₂ in SnO₂ reduces the ON time of the sensors.

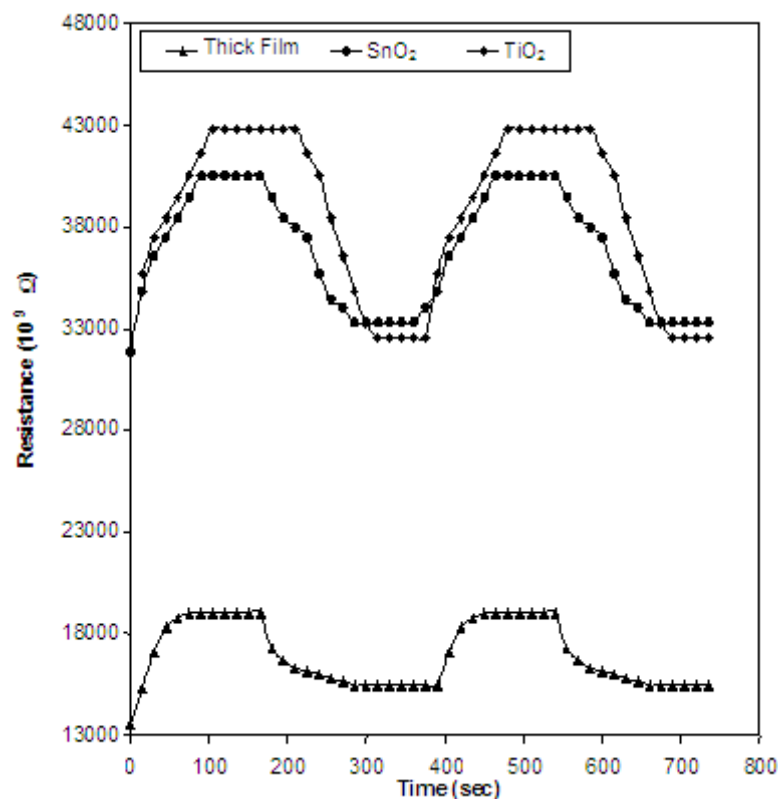


Figure 5: The transient response of CO₂ gas at constant concentration (500ppm)

At temperature 313 K, the change in resistance in presence of CO₂ gas is found to be small, whereas at 343 K the resistance change is appreciable. Addition of Al₂O₃ and TiO₂ in pure SnO₂ never affect the nature of the curves, only the resistance change is observed. The sensitivity of the (SnO₂-10TiO₂-10Al₂O₃) thick film increases by increasing the concentration of CO₂ gas. The surface conductance effects are dominant in sensing the gases. The electrical conductivity (σ) depends on the electron concentration 'n' and this concentration is related to the equilibrium constant and the partial pressure of the gases. The CO₂ gas has oxidizing properties and it leads to an oxidization of material therefore, the conductivity of the material reduces [12-14]. The possible mechanism for CO₂ gas detection in SnO₂ material is based on reactions that occur at the sensor surface, resulting in a change in concentration of adsorbed oxygen. At lower temperature (<150°C), oxygen adsorption at the surface is mainly in the form of O²⁻. Oxygen ions adsorb onto the surface of material removes electrons from the bulk and create a potential barrier that limits electron movement and resistivity. When exposed to an oxidizing gas such as CO₂ then it is chemisorbed on bridging oxygen atoms with the formation of a surface carbonate [15], subsequently increasing the barrier height and the resistivity. Under the presence of O₂ atmosphere, the sensing material chemisorbs gas on its surface. Oxygen can be adsorbed in the several forms such as O₂⁻, O⁻, O²⁻ while, CO absorbs O atom from the surface becoming CO₂.

The small amount of Ti can be disperse at grain boundaries, directly or indirectly affected the density of centers which are active for gas adsorption. The grain size effect i.e. average crystalline size is also important for the sensing mechanism. It has been reported [16-19], that the sensitivity decreases with crystallite size in case of hydrogen and carbon monoxide. The granular and polycrystalline structure plays very important role in the electrical properties. The films, which have a grain size of nanometer order, they facilitated the adsorption process of gas like water molecule in the humidity sensors [7]. In this way the adsorption of CO₂ gas on the surface of thin film takes place through chemisorptions process.

IV. CONCLUSION

The solid solution has been polycrystalline nature and crystallite size found to be order of 10.80 nm. The sensitivity of solid solution is higher than the pure SnO₂ and pure TiO₂. This shows that by the addition of TiO₂ and Al₂O₃ temperature characteristic and stability of the sensor improved. The ON time for this sensor is 60s and OFF time is 105s at 500ppm of CO₂ gas. The resistance of the film increases in presence of CO₂ gas due to decrease in the electron concentration at the surface of the sensor because of oxidization of the material.

References

- [1] Zhang B. Pengbei, Lee C.Chonghoon, Verweij C. Henk, A.Sheikh, C. Akbar, Hunter D. Gary, K. Prabir, A.Dutta, "High temperature sensor array for simultaneous determination of O₂, CO, and CO₂ with kernel ridge regression data analysis", *Sensors and Actuators B*, **123**, 950-963 (2007).
- [2] M. Wierzbicka, P. Pasierb, M. Rekas, "CO₂ sensor studied by impedance spectroscopy", *Physica B*, **387**, 302-312 (2007).
- [3] B. D. Cullity, "Elements of X-Ray Diffraction", Addison-Wesley Publishing Company Inc., London (1978).
- [4] G. T. Lamdhade, S. S. Yawale, S. P. Yawale, "Tin oxide and zinc oxide based doped humidity sensors", *Sensors and Actuators A*, **135**, 388-393 (2007).
- [5] S. P. Yawale, S. V. Pakade, "D.C. conductivity and hopping mechanism in Bi₂O₃-B₂O₃ glasses", *J. Mater. Sci.* **28**, 5451-5455 (1993).
- [6] Seng-Lu ,Yang, Wu Jenn-Ming, "ZrO₂-TiO₂ ceramic humidity sensors", *J. Mater. Sci.*, **26**, 631-636 (1991).
- [7] Radecka Marta, Zokrzewska Katavzyna, Rekas Mieczyslaw, "SnO₂-TiO₂ solid solutions for gas sensors", *Sensors and Actuators B*, **47**, 194-204 (1998).
- [8] A. Dieguez, "Structural analysis for the improvement of SnO₂ based gas sensor", Ph.D. Thesis, Universitat de Barcelona, Barcelona, (1999).
- [9] J. Robertson, "Defect levels of SnO₂", *Phys. Rev. B*, **30** 3520-3522 (1984).
- [10] K. D. Schierbaum, S. Vaihinger, W. Gopel, H. H. Van Den, V. Lekkert, B. Kloeck, N.F. Rooij, "Prototype structure for systematic investigations of thin-film gas sensors", *Sensors and Actuators B*, **1**, 171-175 (1990).
- [11] H. Nanto, T. Morita , H. Habara , K. Kondo, Y. Douguchi, T. Minami, "Properties and sensor performance of zinc oxide thin films", *Sensors and Actuators B*, **35**, 384-387 (1996).
- [12] Marc J. Madou. and Roy S. Morrison, "Chemical Sensing with Solid State Devices", Academic Press Inc., London, (1989).
- [13] Waghuley S.A., Yenorkar S.M., Yawale S.S., Yawale S.P., "Application of chemically synthesized conducting polymer-polypyrrole as a carbon dioxide gas sensor", *Sensors and Actuators B*, **128** 366-373 (2008).
- [14] Waghuley S.A. , Yenorkar S.M., Yawale S.S., Yawale S.P., "SnO₂/PPy Screen-Printed Multilayer CO₂ Gas Sensor", *Sensors and Transducers*, **79**, 1180-1185 (2007).
- [15] Matthias Batzill, U. Diebold, "The surface and materials science of tin oxide", *Progress in Surface Science*, **79**, 47-154 (2005).
- [16] Yamazoe Noboru, "New approaches for improving semiconductor gas sensors", *Sensors and Actuators B*, **5**, 7-19 (1991).
- [17] R.M. Agrawal, "H₂S sensing properties of metal oxide (SnO₂-CuO-TiO₂) thin films at room temperature", *Journal of Electron Devices*, **12**, 730-733 (2012).
- [18] AK Yewale, KB Raulkar, AS Wadatkar, GT Lamdhade, "Application of metal oxide thick film as a NH₃ gas sensor", *Journal of Electron Devices*, **11**, 544-550 (2011).
- [19] GT Lamdhade, KB Raulkar, SS Yawale, SP Yawale, "Fabrication of multilayer SnO₂-ZnO-PPy sensor for ammonia gas detection", *Indian Journal of Physics*, (2015) 1-6, (DOI 10.1007/s12648-015-0676-x).